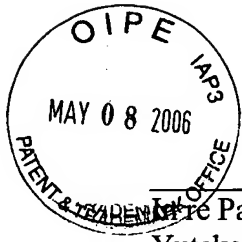


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AMENDMENT TRANSMITTAL LETTER				Docket No. 1248-0673P	
Application No. 10/668,186-Conf. #004125		Filing Date September 24, 2003		Examiner L. M. Schillinger	
Art Unit 2813					
Applicant(s): Yutaka TAKAFUJI et al.					
Invention: SINGLE-CRYSTAL SILICON SUBSTRATE, SOI SUBSTRATE, SEMICONDUCTOR DEVICE, DISPLAY DEVICE, AND MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE					
MS Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450					
Transmitted herewith is an amendment in the above-identified application.					
The fee has been calculated and is transmitted as shown below.					
CLAIMS AS AMENDED					
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate	
Total Claims	57	- 57 =		x	
Independent Claims	14	- 14 =		x	
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					
Other fee (please specify):					
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:					0.00
<input checked="" type="checkbox"/> Large Entity <input type="checkbox"/> Small Entity					
<input checked="" type="checkbox"/> No additional fee is required for this amendment.					
<input type="checkbox"/> Please charge Deposit Account No. _____ in the amount of \$ _____. A duplicate copy of this sheet is enclosed.					
<input type="checkbox"/> A check in the amount of \$ _____ is enclosed.					
<input type="checkbox"/> Payment by credit card. Form PTO-2038 is attached.					
<input checked="" type="checkbox"/> The Director is hereby authorized to charge and credit Deposit Account No. <u>02-2448</u> as described below. A duplicate copy of this sheet is enclosed.					
<input checked="" type="checkbox"/> Credit any overpayment.					
<input checked="" type="checkbox"/> Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.					
<u>Robert W. Duns #48,222</u> Charles Gorenstein Attorney Reg. No.: 29,271				Dated: <u>May 8, 2006</u>	
BIRCH, STEWART, KOLASCH & BIRCH, LLP 8110 Gatehouse Road Suite 100 East P.O. Box 747 Falls Church, Virginia 22040-0747 (703) 205-8000					



Docket No.: 1248-0673P
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inter Patent Application of:
Yutaka TAKAFUJI et al.

Application No.: 10/668,186

Confirmation No.: 004125

Filed: September 24, 2003

Art Unit: 2813

For: SINGLE-CRYSTAL SILICON SUBSTRATE,
SOI SUBSTRATE, SEMICONDUCTOR
DEVICE, DISPLAY DEVICE, AND
MANUFACTURING METHOD OF
SEMICONDUCTOR DEVICE

Examiner: L. M. Schillinger

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated February 7, 2006, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 14 of this paper.